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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1762



Applicant(s): Chiang, Tony P.; Leaser, Karl F.; Brown, Jeffrey A.; Babcoke, Jason E.
Assignee: Angstrom Systems, Inc.
Title: Varying Conductance Out Of A Process Region To Control Gas Flux In
An ALD Reactor
Serial No.: 10/027,592 Filing Date: December 19, 2001
Examiner: Unknown Group Art Unit: Unknown
Docket No.: M-11466-8C US

San Jose, California
January 9, 2002

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

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Respectfully submitted,

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